



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Brintzinger Docket No.: 2002 P 09238 US
Serial No.: 10/732,979 Art Unit: 2811
Filed: December 11, 2003 Examiner: TBD
For: Arrangement for the Protection of Three-Dimensional Structures on Wafers

Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))

Date of Deposit: March 24, 2004

I hereby certify that the below listed correspondence is being deposited with the United States Postal Service on the date indicated above as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450.

Certificate of Mailing via First Class Mail (1 page)
Transmittal of Certified Copy of Priority Document (1 page)
Certified Copy of Priority Document
Information Disclosure Statement (1 page)
IDS Form PTO/SB/08a (1 page) citing (5) references
Copies of (2) cited references
Return Postcard

Respectfully submitted,

Natalie Swider
Legal Assistant

Slater & Matsil, L.L.P.
17950 Preston Rd., Suite 1000
Dallas, TX 75252
Tel: 972-732-1001
Fax: 972-732-9218